

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

In re application of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL MECHANICAL POLISHING APPARATUS AND METHOD TO
MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 3723

Examiner Shantese L. McDonald

Customer No. 23494

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Commissioner for Patents
P.O. Box 1450
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CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

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2-21-00

Jay M. Cantor, Reg. No. 19,906

NOTICE OF APPEAL

Sir:

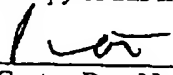
Applicant hereby appeals to the Board of Appeals from the decision dated January 25, 2006 of the Primary Examiner finally rejecting claims 1, 2, 4 to 8 and 10 to 15, all of the rejected claims.

The item(s) checked below are appropriate:

1. ☐ An extension of time to respond to the final rejection
☐ was granted on
☐ is requested for _____ month(s).
2. ☐ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.
3. ☒ Fee \$500.00:
☐ Not required (*Fee paid in prior appeal*)
☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Account No. 20-0668. A duplicate copy of this sheet is enclosed.

Signature [Rule 191(b)]

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(to which correspondence is to be sent)


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On the date stamped here, the following paper was
received in the Patent and Trademark Office in the
below listed application:

Notice of Appeal

Inventor(s): Michael Shu-Huan Wang et al.
Serial No 10/718,921
Filed November 21, 2003
For: Chemical-Mechanical Polishing Apparatus...
Docket Number: TI-34402

